



AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP ART UNIT: 2812

PATENT APPLICATION
Q-51885

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Akitaka KIMURA

Appln. No.: 09/161,981

Group Art Unit: 2812

Confirmation No.: 8269

Filed: September 29, 1998

Examiner: Mulpuri, S

For: SEMICONDUCTOR LAYER FORMED BY SELECTIVE DEPOSITION AND
METHOD FOR DEPOSITING SEMICONDUCTOR LAYER

AMENDMENT UNDER 37 C.F.R. § 1.116,
REQUEST FOR RECONSIDERATION,
AND
REQUEST FOR INTERVIEW

BOX AF

Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the "final" Office Action (Paper No. 18) mailed November 20, 2002,
please amend the above-identified application as follows:

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-5/2/3

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14325 201
10 2000 1000 1000

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U.S. APPLN. NO. 09/161,981

IN THE DRAWING

See the enclosed Proposed Drawing Correction.